

Docket No. N1085-00040
Inventor: Ming-Shuoh Liang et al.
"A Method Of Providing Via In A Multilayer Semiconductor Device
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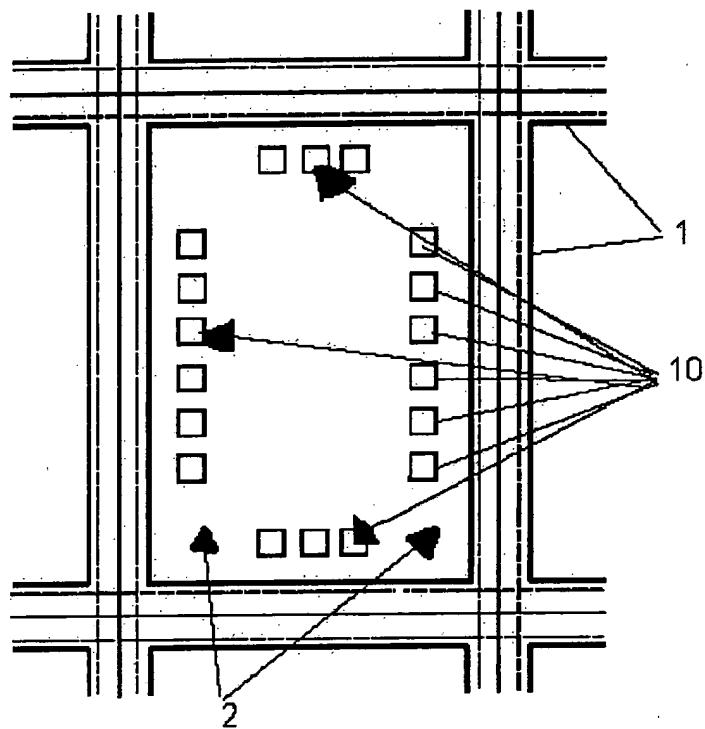


FIG. 1 (PRIOR ART)

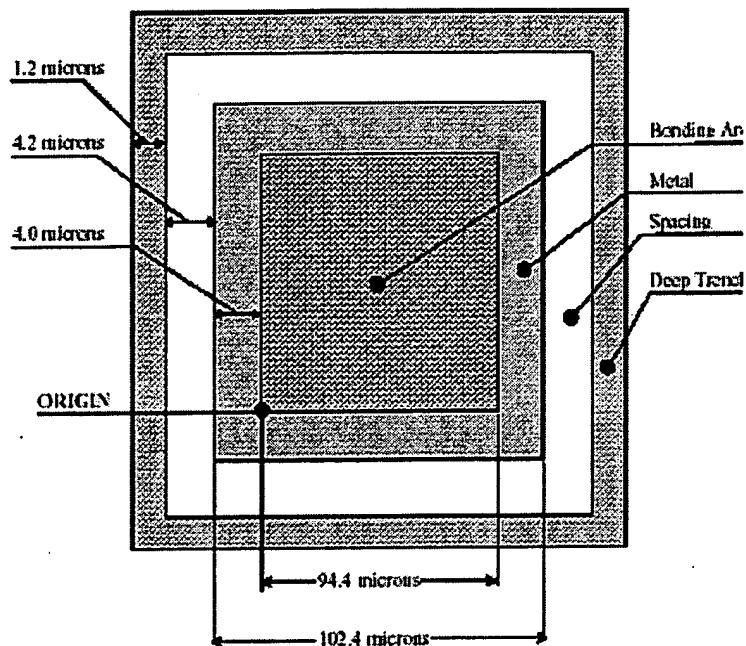


FIG. 2a (PRIOR ART)

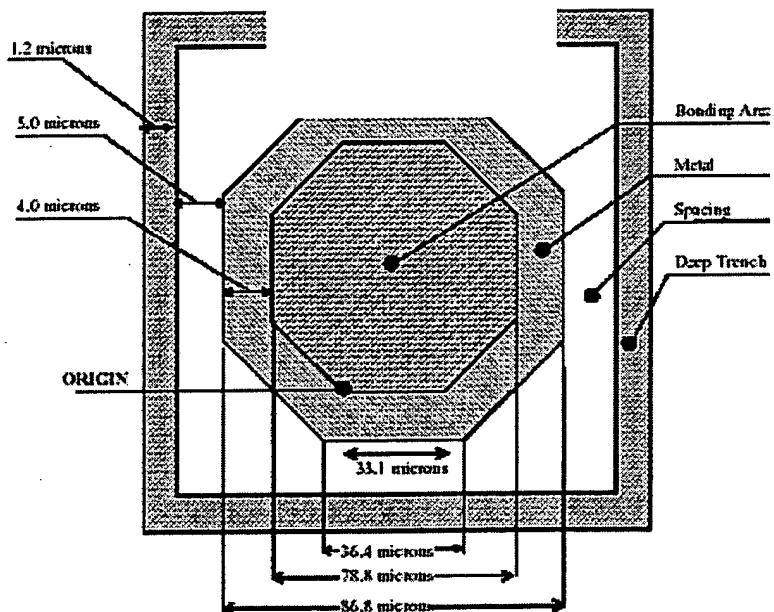


FIG. 2b (PRIOR ART)

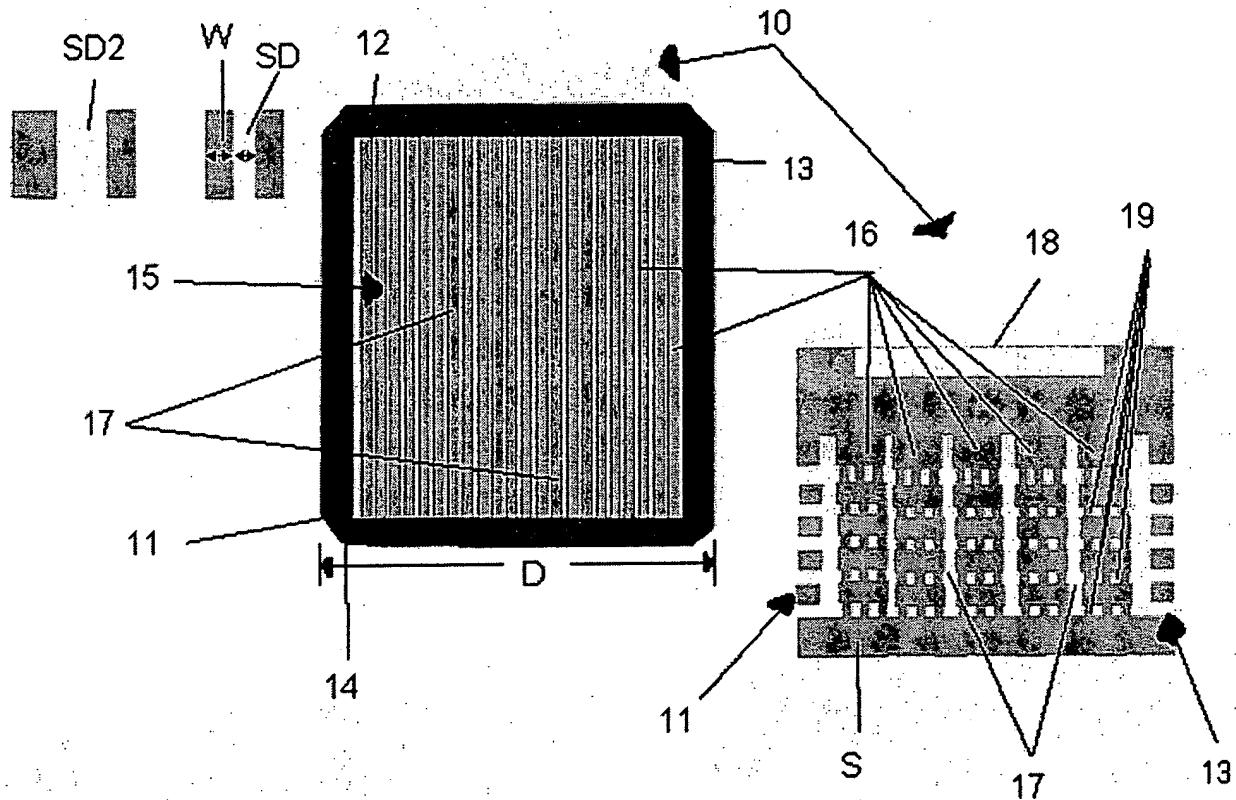
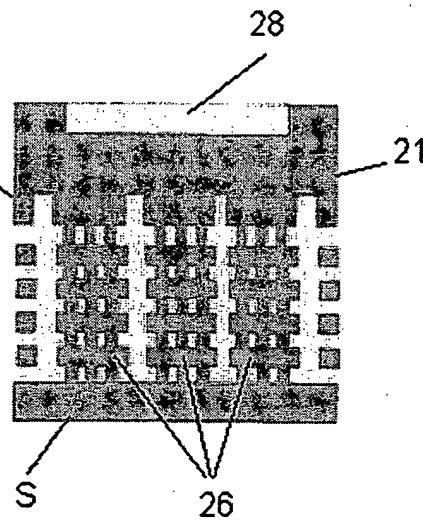
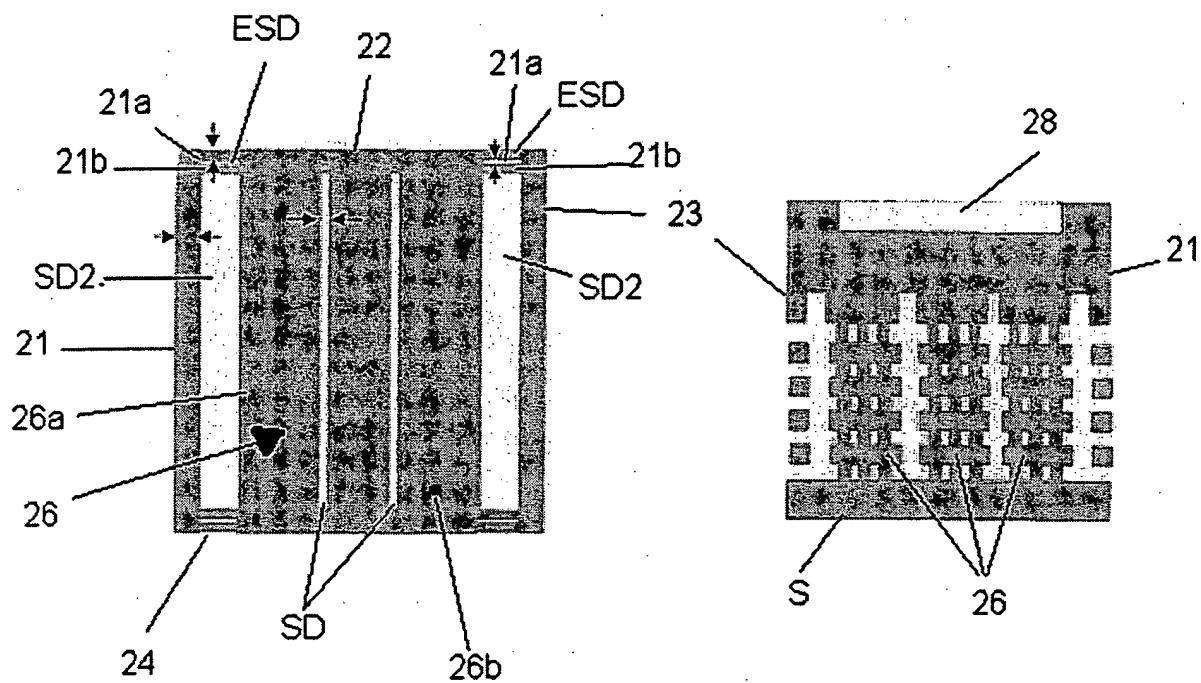
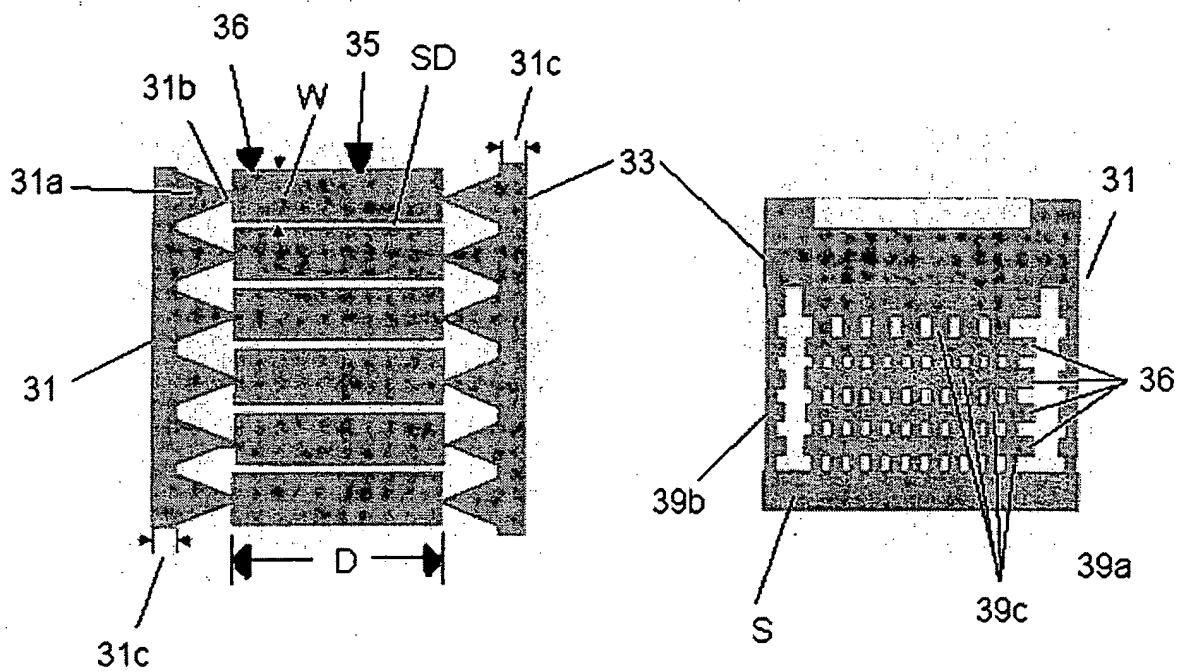


FIG. 3a

FIG. 3b



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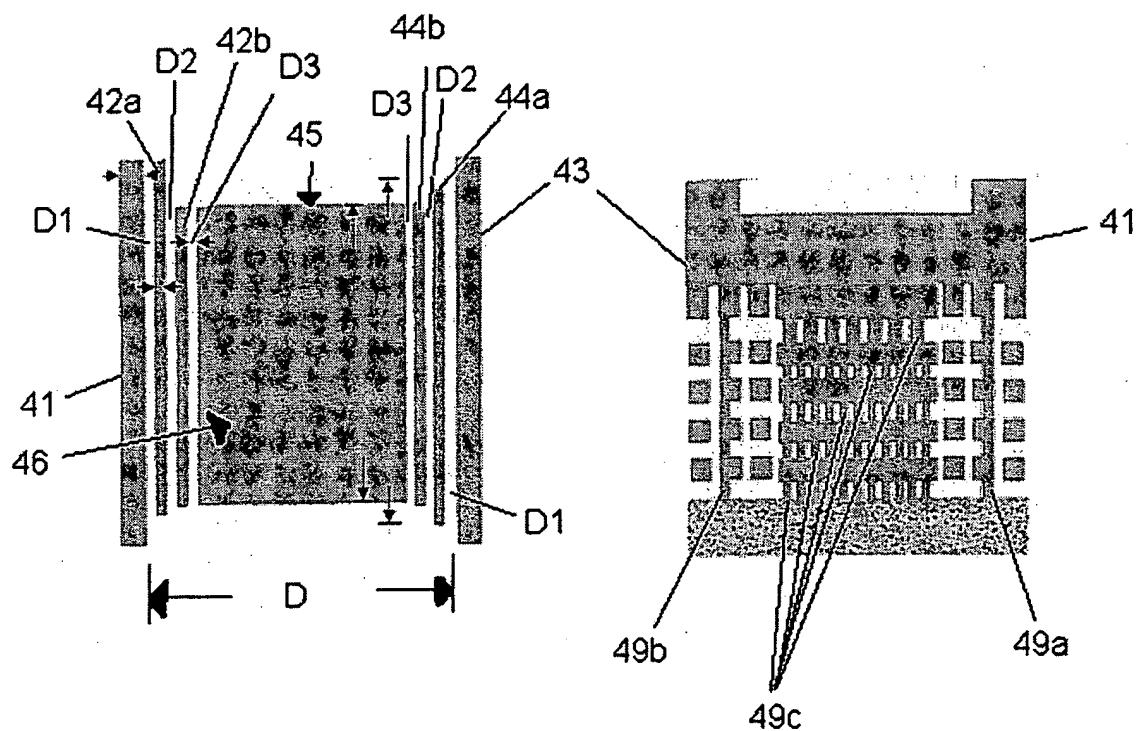


FIG. 6a

FIG. 6b